

APPLICATION DATA SHEET

Electronic Version v14
Stylesheet Version v14.0

Title of Invention METHOD FOR DEPOSITING HIGH-QUALITY MICROCRYSTALLINE SEMICONDUCTOR MATERIALS

Application Type:

regular, utility

Attorney Docket Number: USS-18302/16

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as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.